

Electronic Filing System (EFS) Data

Electronic Patent Application Submission

USPTO Use Only

EFS ID: 63570
Application ID: 10710255 
Title of Invention: METHOD OF FORMING STRAINED
SI/SIGE ON INSULATOR WITH
SILICON GERMANIUM BUFFER
First Named Inventor: Huajie Chen
Domestic/Foreign Application: Domestic Application
Filing Date: 2004-06-29
Effective Receipt Date: 2004-06-29
Submission Type: Utility Patent Filing
Filing Type: new-utility
Confirmation number: 4254
Attorney Docket Number: FIS920030381US1

Total Fees Authorized: 810.0
Payment Category: Deposit Account
Deposit Account Number: 90458
Deposit Account Name: Margaret A. Pepper
RAM Payment Status: RAM has not been processed

Digital Certificate Holder: cn=Margaret A. Pepper,ou=Registered Attorneys,ou=Patent and
Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US
Certificate Message Digest: f5edd41354ac987f3b02e338809facfdc4ee33e7